

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/609,263	ELDRIDGE, BENJAMIN N.	
Examiner	Art Unit	
Paul D. Kim	3729	

	SEARCHED					
Class	Subclass	Date	Examiner			
29	592.1 593 831 832	7/26/2005	PK			
324	763 765					
	158.1					
438	14, 17	V				

INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
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SEARCH NO (INCLUDING SEARC)
	DATE	EXMR
Reviewed Parent Application 09/955,258 (US PAT. 6764869)	7/26/2005	PK
Consulted by Rich Booth (438)	7/26/2005	PK
Vinh Nguyen (324)	7/26/2005	PK
Text Search EAST/NPL (IEEE)	7/26/2005	PK
Updated Text Search EASt	2/24/2006	PK